



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:		)	
		:	Examiner: Not Yet Assigned (FC)
KIYOFUMI SAKAGUCHI, ET AL.		)	
		:	Group Art Unit: 2813
		)	
Application No.: 10/085,046		:	22
		)	2300
Filed: March 1, 2002		:	
		)	
For:	PROCESS FOR	:	
	PRODUCTION OF	)	
	SEMICONDUCTOR	:	
	SUBSTRATE	)	June 26, 2002

Commissioner for Patents Washington, D.C. 20231

## SECOND PRELIMINARY AMENDMENT

Sir:

Prior to action on the merits, please further amend the above-identified application as follows:

## IN THE SPECIFICATION:

Please amend paragraph [0001] to read as follows. A marked-up copy of the paragraph showing the changes made can be found in the attached appendix:

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This application is a continuation-in-part of application number 09/161,775 filed September 29, 1998, pending, which was a division of application 08/863,717 filed May 27, 1997, now U.S. Patent 5,856,229, which was a continuation of application number